

SIHI[®] Dry GD S Sizes S450, S650

Single Stage Vacuum System - General Design Dry Running Screw Vacuum Pump



Experience In Motion



Pressure range:

Pumping Speed:

< 0.001 to 1013 mbar 0.00075 to 760 torr 450 to 650 m³/h 265 to 383 cfm

DESIGN

SIHI[®] Dry vacuum systems have been especially developed for use in industrial applications. It is based upon a dry running twin screw principle working as a single stage vacuum pump.

- No wear parts / contact-free shaft sealing
- Low ultimate pressures with only one stage vacuum pump
- High resistance regarding particles due to big gaps and Top Down flow
- Silent operation
- Lowest vibration level
- Absolutely free of oil / no gear oil
- Plug & Pump for shortest commissioning
- Permanent pump protection by electronically overload function
- Disassembly and assembly of the pump chamber can be done insitu by own staff members
- Bluetooth, CANopen and I/O interface already included
- Various bus communication protocols available

The **SIHI**[®] **Dry S-Version** has been designed to perform maximum pumping speed already at atmospheric pressure. This offers fast volume evacuation coming from higher pressure.



APPLICATION

The **SIHI**[®] **Dry** is used for all industrial applications, where a robust and high reliable dry vacuum pump is required.

The flexibility of the modular system allows to be adapted to any process conditions. Thus the innovative drive concept and its optional additional features, such as the regulation of the speed to meet the requirement of the system, offers the possibility to considerably reduce the power absorption.

NOTE

In contradiction to conventional pumps with mechanical gear box shaft synchronisation, **SIHI® Dry** spindles are electronically synchronized. This well established, innovative concept enables a silent operation of the vacuum system; it also makes all efforts for maintaining and changing gear oil obsolete.

SIHI [®] Dry		S450	S650			
Max. eff. Pump Speed	m³/h (cfm)	450 (265)	700 (412)			
Ultimate pressure	mbar a (mtorr a)	< 0.005 (3.75)	< 0.001 (7.5)			
Power consumption at ultimate press.	kW (hp)	≤ 4 (≤ 5.4)	≤ 6 (≤ 8)			
Max. discharge pressure	mbar g (torr g)	100 (75)				
Gas inlet temperature	°C (°F)	0 to +100 (+32 to +212)				
Gas outlet temperature	°C (°F)	< 200 (< 392) < 275 (< 52				
Temperature of cooling water	°C (°F)	+10 bis +40 (+50 to +95)				
Noise emission ¹	dB (A)	< 75				
Weight, approx.	Kg (lbs)	400 (882)				

GENERAL TECHNICAL DATA

ELECTRICAL DATA

SIHI [®] Dry		S450	S650
Power system	-	L1, L2, L3, PE (without N)	
Voltage	V AC	380 to 500 ± 10%	
Frequency	Hz	50 to 60	
Control voltage / max. control current	V DC / A	24 / 4	
Protection class (DIN EN 60529)	-	IP54	
Power consumption at ultimate pressure	kW (hp)	$\leq 4 \ (\leq 5.4) \qquad \qquad \leq 6 \ (\leq 8)$	
Max. power consumption	kW (hp)	12 (16)	
Fuse protection - all poles	A	32	

PURGE GAS (SEALING GAS)

SIHI [®] Dry		S450	S650
Medium	-	N ₂ , CDA, CO ₂	
Gas purity		min Class 2.4.2 (following ISO 8573-1:2010)	
Consumption in operation	NI/min (SCFM)	20 (0.71)	
Pressure	bar g (psi g)	6 bis 8 (87 to 116)	

COOLING WATER

SIHI [®] Dry		S450	S650
Medium	-	Water conductivity > 50 µS (DI water on request)	
Cooling water temperature	°C (°F)	10 to 40 (50 to 104)	
Max. adm. static pressure	bar g (psi g)	6 (87)	
Min. flow	l/min (gpm)	7 (1.85)	

MATERIAL DESIGN

In contact with progress medium / coolant



SIHI [®] Dry		S450	S650
Casing	10	EN-GJS-400-18-LT	
Twin screw spindle	20	EN-GJS-500-14	
Cooling circuit	30	brass, brass nickel plated, PUN, 1.4021, EN-GJS-400-18-LT, EN-GJL-250	
Bearing cartridge	40	1.4021	
Motor casing	50	EN-GJL-250	



NOT JUST A PUMP! YOUR SOLUTION FOR ...

... LOW EFFORTS IN ENGINEERING & INTEGRATION OF SYSTEM COMPONENTS

CUSTOMIZED SOLUTIONS

+ Pre-engineered modules matches all individual process needs

NO ACOUSTIC COVER NECESSARY

+ Contact free principle offers quiet operation and comfortable environmental conditions

NO PRESSURE REGULATOR VALVE NECESSARY

+ Adjustable suction capacity by variable speed

MORE AN INTEGRATED SOLUTION THAN JUST A PUMP

- + Pre-engineered modules are assembled & tested in one vacuum system
- + Small foot print design saves useful space

EASY COMMUNICATION INTEGRATION **DUE INDUSTRIAL STANDARDS**

+ Availability of all Bus standards as well as I/O interface



Cleaning

... FASTEST INSTALLATION & START UP

PLUG & PUMP CONCEPT

+ Equipped with quick connectors for process and supply media as standard (optional)

... LOWEST DOWN TIME

ONLY CLEANING ON DEMAND

+ Condition monitoring by independent data record of both shafts

DESIGNED FOR IN SITU CLEANING

- + Easy dismantling without bearing removal
- + No high-tech workshop required
- + Can be done on site by own staff
- + Independency on 3rd party service performance



+ No gear oil

Maintenance

NO WEARING

- + Consequent touch-less principle
- + Long life bearings
- + Contact-free sealings

CONTINUOUS CONDITION ANALYSIS

Design allows vertical and horizontal flow direction Direct connection to a vacuum chamber is possible

90°

- + Data logging + Online monitoring of pump status
- + Simple failure codes



ZERO PROCESS CONTAMINATION + Truly dry and touch-less principle with free

- of any service liquids + Absolutely free of gear oil due to electrical
- synchronised shafts

... LOWER COST FOR OPERATION

LOW POWER CONSUMPTION

- + High-tech screws design is aimed to run with most energy efficiency
- + Frequency control allows to improve energy efficient operation by operators

ROBUST & RELIABLE

+ Pump design without any coating on screws

.. CAPABILITY FOR USE IN HARSH **PROCESSES**

TOLERATES PARTICLE & LIQUID CARRY OVER WITHOUT ANY SUCTION SIDE FILTER

- + Top Down flow avoids particle deposits inside of the pump
- + Carrying particles does not result in wear due to consequential contact free principle
- + Optional integrated liquid cleaning by flushing module
- + Particle carry over & pump drying by optional integrated gas dilution module

HANDLES CONDENSABLE & CORROSIVE **MEDIA**

- + Prevention of condensation inside of the pump by optional integrated gas dilution module
- + Optional integrated liquid cleaning by flushing module
- + Reduction of condensation by temperature controlled operation

TROUBLE FREE PUMPING OF SENSITIVE **MEDIA**

+ Temperature controlled operation

Easiest cleaning on site



Service

... LOWEST DOWN TIME

- FASTEST EXCHANGE OF VACUUM SYSTEM ON SITE
- + Fast exchange of vacuum system
- + Can be done on site by own staff

+ Quick connectors offers Plug & pump

- DESIGNED FOR ON-SITE SERVICE
- + Standard spindle exchange modules
- + No high-tech workshop required + Can be done on site by own staff
- + Independency on 3rd party service performance

FASTEST REMOTE FAILURE ANALYSIS

- + Continuous data logging allows
- comprehensive understanding of system conditions
- Prepared for online condition monitoring
- + Simple failure codes



PUMP SPEED CURVE



The operating Data is valid under following conditions:

- •
- Process media : dry air 20°C (68°F) Coolin water inlet : water: 25°C (77°F) ٠
- Discharge pressure : 1013 mbar (760 torr) •
- The suction volume is related to the suction pressure •

Tolerance on operating data is ± 10%

DIMENSIONS – vertical orientation



SIHI [®] Dry		S450	S650
Inlet	N1	DN 80 / ISO-F 100 / ANSI 3"	
Outlet	N2	ISO-F 63	
Purge gas supply inlet	N4.1	NPT ³ / ₈ " internal thread - quick coupling (optional)	
Coolant inlet	N5	NPT ¹ / ₂ " internal thread - quick coupling (optional)	
Coolant outlet	N6	NPT ¹ /2" internal thread - quick coupling (optional)	



DIMENSIONS – horizontal orientation

Dimensions in mm [inch]



SIHI [®] Dry		S450	S650
Inlet	N1	DN 80 / ISO-F 100 / ANSI 3"	
Outlet	N2	ISO-F 63	
Purge gas supply inlet	N4.1	NPT ³ / ₈ " internal thread - quick coupling (optional)	
Coolant inlet	N5	NPT ¹ /2" internal thread - quick coupling (optional)	
Coolant outlet	N6	NPT 1/2" internal thread - quick coupling (optional)	

STANDARD MODULS and ACCESSORIES

MODULS AND ACCESSO	RIES	FEATURES
VACUUM PUMP		
SIHI [®] Dry S450 / S650	 Pump unit integrated drive motors integrated drive control unit integrated monitoring of power and media supply 	Double shafted screw spindles / displacers rotate contact free in reverse direction. Integrated monitoring of cooling water supply and compessions and seal gas pressure.
PUMP CONTROL		
BASIC	 In Pump integrated pump control Monitoring and Control of internal temperature Monitoring and Control of torque Monitoring of seal gas pressure Monitoring of back pressure (exhaust) Electronically overload protection On-site operation via Tablet-PC, SIHI® BT- Remote App via Bluetooth® communication 	Commands: Start, Stop, Reset 24V supply voltage Communications: signal output (4 pins) Status Messages: Operation and failure signal
		NO valve actuation / control
		NO sensor analysis
SIHI Control FX	Like control variant BASIC, additionally:	Commands: Start, Stop, Vacuum, Shut Down, Reset
Characteristic diagram:	 variable speed via integrated frequency converter 	Communications: IO interface (17 pins)
Process flow diagram:	 On-site operation via Tablet-PC, SIHI® BT- Remote App via Bluetooth® communication and Vacuum pump integrated SIHI Control FX sequence control FX = Fixed parameter 	Speed set point: Analog (4-20mA) Status Messages: Operation, Warning, Failure, Failure signal, Vacuum,
Warm Up Warm Shartbereit Warm Shartbereit Warm Shartbereit Warm Shartbereit Warm Shartbereit Warm Shartbereit Vacuum request Vacuum Anforderung Vacuum peration Vacuum Betrieb	 Data logger Display of operation mode Programmed valve control (for all standard valves) Input for analog signals Digital status messages 	Shut Down, Actual speed (4-20mA) Control of following valves: - Shut-Off Valve (suction side) - Seal gas - Gas dilution - Cleaning / Flushing - Liquid purge - Gas purge Analysis of following sensors: - Pressure switch - Temperature sensor
SIHI CONTROL FX BUS	Like control variant SIHI Control FX, additionally:	Commands , Cleaning
Characteristic diagram:	 Electrical connection via BUS interface Detailed status messages via BUS interface Detailed warning messages via BUS interface Detailed failure messages via BUS interface Speed settings via BUS interface 	Communications: PROFIBUS PROFINET EtherCAT Ethernet IP Modbus TCP Speed set point : Digital Status Messages: Operation, Vacuum Mode None Failure, Warning, Failure, Cleaning, Actual speed



MODULS AND ACCESSO	RIES	FEATURES
FRAME		
	<u>Vertical Version</u> In this version the whole pump unit is mounted in vertical position to optimize the Top Down Flow. Thus the pump can be integrated in each customer machinery concept with the lowest floor-footprint.	
	Horizontal Version In this version the whole pump unit is mounted in horizental position. Thus the pump can be integrated in each customer machinery concept with the lowest installation height.	
COOLING		
	Direct Cooling The vacuum pump is directly connected to the customers cooling system (no DI water). Important: Supplied coolant quality must conform to the vacuum system specifications.	Material Design: Cooling media-accessible components: Brass, brass nickel plated, PUN, stainless steel, GJL, GJS cooling water connections: Standard :NPT ¹ / ₂ " (IG) Ontionial :quick coupling
	Direct Cooling with Thermostatic Valve (3-Way) The vacuum pump is directly connected to the customers cooling system (no DI water). For adjusting the working chamber temperature, the cooling circuit is equipped with a thermostatic valve (3-Way) optinally. Within certain technical limits, deposition layers and condensation can so be avoided.	Material Design: Cooling media-accessible components: as described in Direct Cooling + thermostatic valve: Brass cooling water connections: Standard :NPT ¹ / ₂ " (IG) Optionial :quick coupling
	Secondary Cooling with Circulation Pump The vacuum pump is not directly connected to the customers cooling system. The cooling circuit of the vacuum pump and the customers cooling circuit are decoupled by a plate heat exchanger. It is possible to use special coolants e.g. DI water (on request). In the cooling circuit of the vacuum pump, a thermostatic valve is installed for adjustable working chamber temperature to avoid or minimize process particle deposition and condensation. The vacuum system is generally equipped with quick-couplings.	Materia Design: water-accessible components Brass, brass nickel plated, stainless steel cooling water connections: Standard :NPT 1/2" (IG) Optionial :quick coupling

MODULS AND ACCESSO	RIES	F	FEATURES
SUCTION SIDE ACCESSO	DRIES		
	Shut-Off ValveIsolation of the vacuum pump from the inlet line.A pneumatic driven butterfly shut-off valve on the suction side isolates the pump from the recipient.Backflow through the pump and ventilation of the reactor are avoided.When power and gas supply fails, the valve is automatically closed by an internal spring return (NC).Note: Sieve flange adaptor needed!	 Scope of Supply Shut-Off Valve Actuator is des 6 bar g (The valve is fu into the vacuus 	e, GJL/stainless steel/ FKM signed for a pressure of (87 psi g), spring return Illy mounted and integrated m system.
9	Sieve flange adaptor Optional adapter for installation of sensors and/or purge/flushing valves on suction side on systems with flame arresters.	Material:	Stainless Steel
	Coarse strainer Mechanical damages caused by bigger particles can be prevented by an optionally installed Coarse Screen or Sieve <u>Note:</u> Sieve slot / flange adaptor needed when DIN flange connector is used!	Material: Mesh size: Wire thickness:	Stainless Steel 4.0 mm [0.16 inch] 0.9 mm [0.0354 inch]
	Fine strainerMechanical damages caused by smaller particles or process flakes can be prevented by an optionally installed Fine strainer. Recommended for commisioning start up purposes.Note:Sieve flange adaptor needed when DIN flange connector is used!	Material: Mesh size: Wire thickness:	Stainless Steel 1.2 mm [0.0472 inch] 0.33 mm [0.013 inch]
GAS SEALING			
	SIHI[®] Dry is using wear free static labyrinth seals between shaft and working chamber. These seals are purged with sealing gas.	Important: Supplied gas qualit system specificatio	ty must conform to the vacuum ns.
GAS DILUTION			
	This optional, additional gas dilution can be added in order to handle larger amounts of particles or excessive amounts of condensable vapor. In order to prevent too high purge gas consumption, this option only gets activated by the control in "Vacuum Mode". <u>Note:</u> The pressure of gas dilution complies with the pressure of gas sealing	 Scope of Supply 2-way, 2-positi solenoid valve of 6 bar g (87) Flow meter 40 adjustable by a 	ion valve, NC direct-acting , designed for CDA pressure psig), spring return, brass 0 – 4000 NI/h (14.1 – 141 cfh), a needle valve



MODULS AND ACCESSORIES		FEATURES
GAS- AND LIQUID FLUSH	ling	
The	The optional, additional gas purge by any type of inert gas can be added in order to dry and / or to get all residual process gases or condensable vapor out of the pump's suction chamber. An optional, additional liquid purge can help to rinse all particles / flakes or depositions out of the pump. This function can be activated by the software. Note: Sieve flange adaptor needed!	 Scope of Supply 2-way, 2-position valve, NC direct-acting solenoid valve, designed for CDA pressure of 6 bar g (87 psig), spring return, brass Magnetic valve Pressure reducer Needle valve
DISCHARGE SIDE ACCES	SSORIES	
Ø	Wafer Type Lift Check Valve Separation of vacuum pump and exhaust line The pump is isolated to the exhaust line to avoid condensation of process gases after the pump is switched off.	Scope of Supply - Wafer Type Lift Check Valve - Spring return Material: Stainless Steel
	Silencer Discharge side absorption silencers reduce the exhaust noise emissions to a minimum.	Material: Stainless Steel
Q.	Adaptor flange discharge side ISO-F63 auf DN 80 PN16 / ANSI 3"	Material: Stainless Steel



NOTE!

The above information is intended for guidance only and the company reserves the right to change any data herein without prior notice!

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